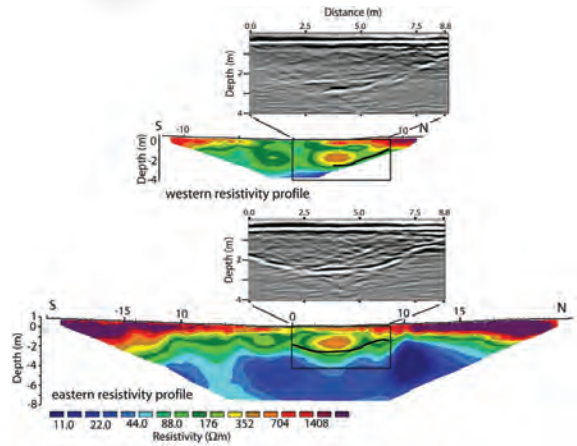
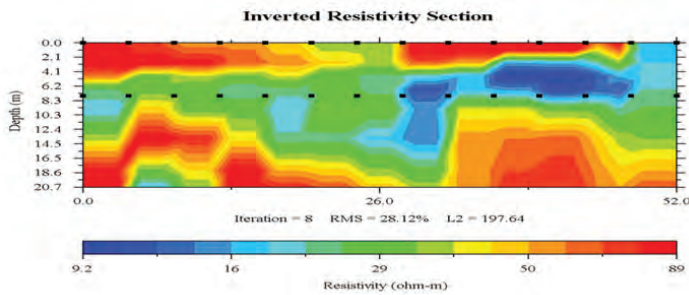
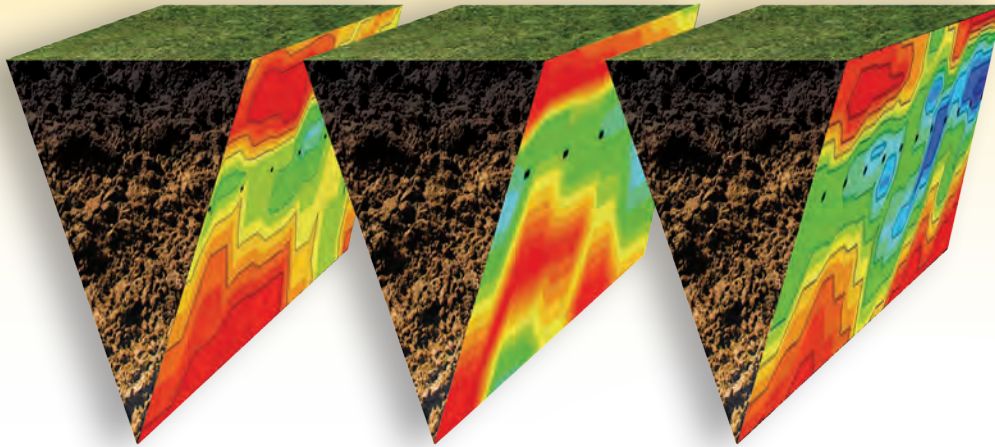
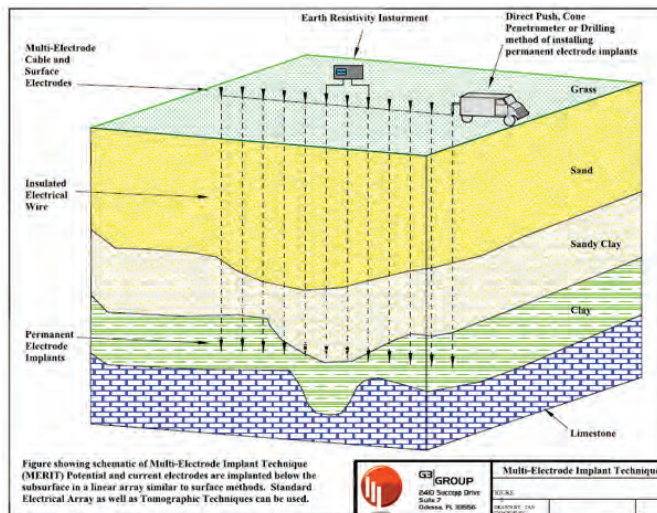


The G3 Group's Advanced Geophysical Technique Multi-Electrode Resistivity Implant Technique (MERIT)



Comparison of an image of a sinkhole at the USF Geo-Park, using ground penetrating radar, electrical Resistivity and **MERIT**.

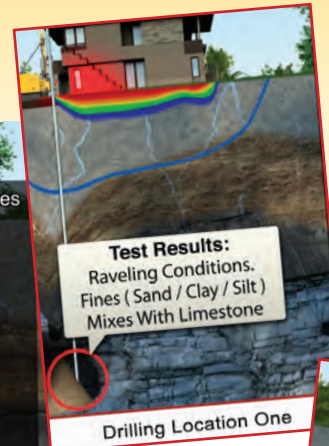
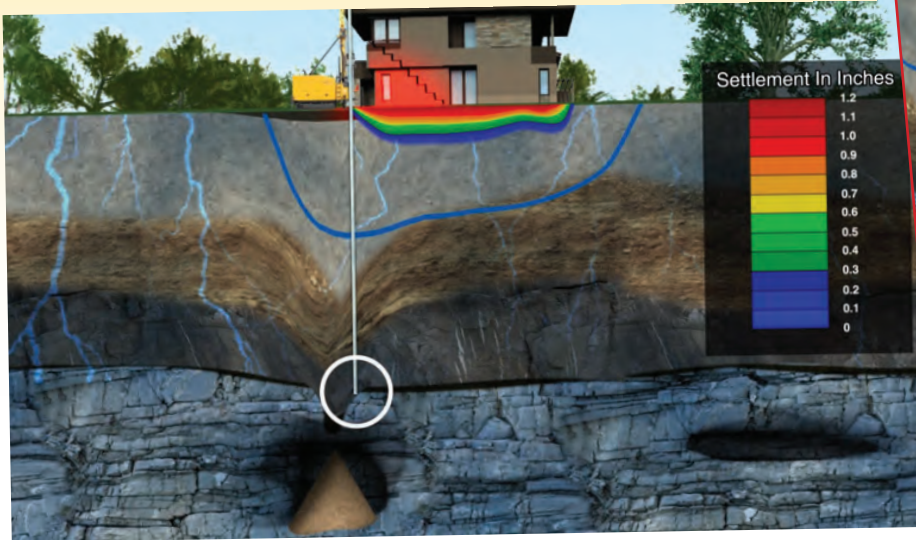
Surface methods only image the near surface clay layer, while the **MERIT** can image the entire subsurface including topography of the limestone.



The G3 Group uses direct push technology to install **MERIT** as a rapid and cost effective method of Deployment. The implants are robust and can be utilized over extended periods of time.

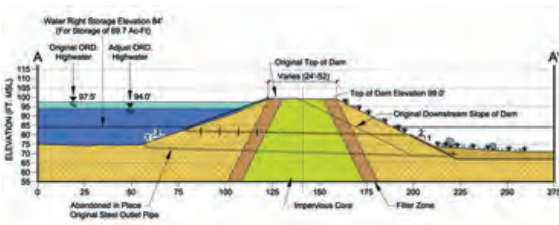


The G3 Group's Advanced Geophysical Technique Multi-Electrode Resistivity Implant Technique (MERIT)

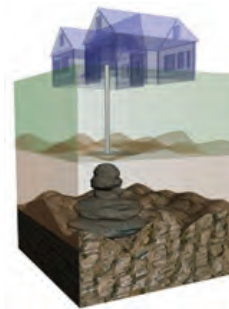


MERIT can be utilized to direct the geotechnical drilling by targeting specific locations at depth. **MERIT** provides an increased level of confidence of the subsurface investigation and remedial actions

Additional Applications for MERIT



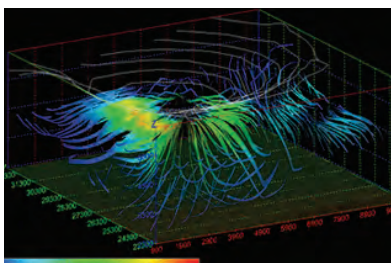
Earthen Dams



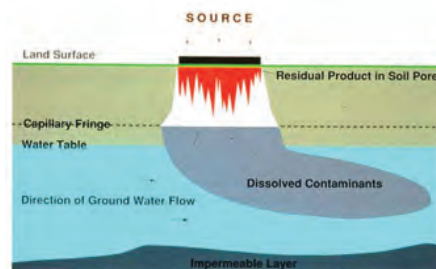
Imaging Subsurface Grouting



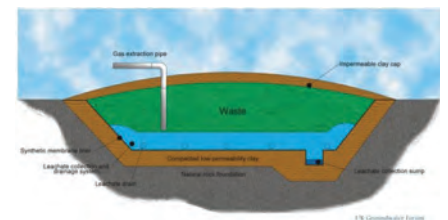
Infrastructure Ground Subsidence Issues



Groundwater Modeling



Imaging Groundwater Contamination Impermeable Layers, and Remediation efforts



Monitoring Landfills